

UNITED STATES PATENT AND TRADEMARK OFFICE

BEFORE THE PATENT TRIAL AND APPEAL BOARD

ASML NETHERLANDS B.V., EXCELITAS TECHNOLOGIES CORP., AND
QIOPTIQ PHOTONICS GMBH & CO. KG,
Petitioner,

v.

ENERGETIQ TECHNOLOGY, INC.,
Patent Owner.

Case IPR2015-01368
Patent 8,525,138

MAIL STOP PATENT BOARD
Patent Trial and Appeal Board
United States Patent and Trademark Office
Post Office Box 1450
Alexandria, Virginia 22313-1450

**ENERGETIQ TECHNOLOGY, INC.'S MOTION FOR
PRO HAC VICE ADMISSION OF FABIO E. TARUD**

I. Statement of Precise Relief Requested

Pursuant to 37 C.F.R. § 42.10, Patent Owner Energetiq Technology, Inc. (“Energetiq”) requests that the Board admit Fabio E. Tarud *pro hac vice* in this proceeding.

II. Good Cause Exists for the Board to Recognize Counsel *Pro Hac Vice* During the Proceeding

In accordance with 37 C.F.R. § 42.10(c), the Board may recognize counsel *pro hac vice* during a proceeding upon a showing of good cause, subject to the condition that lead counsel be a registered practitioner and to any other conditions as the Board may impose. More specifically, 37 C.F.R. § 42.10(c) indicates that “where the lead counsel is a registered practitioner, a motion to appear *pro hac vice* by counsel who is not a registered practitioner may be granted upon showing that counsel is an experienced litigating attorney and has an established familiarity with the subject matter at issue in the proceeding.” The facts here establish good cause for the Board to recognize Fabio E. Tarud *pro hac vice* during this proceeding.

Lead Counsel, Steven M. Bauer, is a registered practitioner, having USPTO Registration No. 31,481.

Counsel, Fabio E. Tarud, is an experienced patent litigator and has an established familiarity with the subject matter at issue in the proceeding.

Accompanying this motion is the Declaration of Fabio E. Tarud in Support of Motion for Admission *Pro Hac Vice* (Ex. 2086). Mr. Tarud is a litigating attorney

with over 5 years of patent litigation experience. Ex. 2086 at ¶¶ 9-10. He is a member in good standing with the Bar of the State of New York. *Id.* at ¶ 2. He has never been suspended, disbarred, sanctioned, denied admission to practice, or cited for contempt by any court or administrative body. *Id.* at ¶¶ 3-5. Mr. Tarud is familiar with the subject matter at issue, and his technical experience will aid Energetiq in this proceeding. *Id.* at ¶ 11. He also satisfies the remaining conditions for admissibility identified by the Board. *See Id.* at ¶¶ 6-8.

III. Conclusion

For the foregoing reasons, Energetiq respectfully requests that the Board admit Fabio E. Tarud *pro hac vice* in this proceeding.

Respectfully submitted,
Proskauer Rose LLP

/ Steven M. Bauer /
Steven M. Bauer, Reg. No. 31,481
Attorney for Patent Owner

Date: April 4, 2016
PROSKAUER ROSE LLP
One International Place
Boston, Massachusetts 02110

PATENT OWNER'S EXHIBIT LIST

Exhibit #	Document
2001	Declaration of Safraz W. Ishmael in Support of Motion for Admission <i>Pro Hac Vice</i>
2002	Declaration of Jinnie L. Reed in Support of Motion for Admission <i>Pro Hac Vice</i>
2003-2005	<Reserved>
2006	J. Gary Eden Dep. Transcript Excerpts
2007	Raizer, <i>Gas Discharge Physics</i> , pp. 35-51, 306-310 (1st ed. 1991)
2008	<Reserved>
2009	" <i>Photon Source, Metrology Apparatus, Lithographic System and Device Manufacturing Method</i> ," U.S. Pub. No. US 2013/0329204 A1 (December 12, 2013)
2010	<Reserved>
2011	Raizer, <i>Gas Discharge Physics</i> , pp. 35-51, 306-310 (Corrected 2nd Printing 1997)
2012	Eden's ECE 523 Syllabus (Spring 2016)
2013	Zimakov et al., " <u>Interaction of Near-IR Laser Radiation with Plasma of a Continuous Optical Discharge</u> ," <i>Plasma Physics Reports</i> , Vol. 42, No. 1 (2016)
2014	Bezel et al., "High Power Laser-Sustained Plasma Light Sources for KLA-Tencor Broadband Inspection Tools" (undated)
2015	<Reserved>
2016	Smith Declaration
2017-2019	<Reserved>
2020	Rudoy et al., " <u>Xenon Plasma Sustained by Pulse-Periodic Laser Radiation</u> ," <i>Plasma Physics Reports</i> Vol. 41, No. 10 (2015) ("Rudoy")
2021	Eden Depo Ex. 5 (Knecht et al., " <u>Optical pumping of the XeF(C-+A) and iodine 1.315-μm lasers by a compact surface discharge system</u> ," <i>Optical Engineering</i> , Vol. 42, No. 12 (2003))
2022	Fridman et al., <i>Plasma Physics and Engineering</i> , pp. 404-419, 618-619 (1st ed. 2004)
2023	Webster's Third New International Dictionary of the English Language, Unabridged, "Sustain," p. 2304 (2002)
2024	Merriam-Webster Dictionary, "Sustain," pp. 722-23 (2004)

Exhibit #	Document
2025	The American Heritage Dictionary of the English Language, "Sustain," p. 1744 (4th ed. 2006)
2026	Curriculum vitae of Donald K. Smith
2027-2028	<Reserved>
2029	Zimakov et al., "Bistable behavior of a continuous optical discharge as a laser beam propagation effect" (2013)
2030-2044	<Reserved>
2045	I.N. Toumanov, " <u>General Analysis of Plasma Technique in Chemical Technology and Metallurgy</u> ," Plasma and High Frequency Processes for Obtaining and Processing Materials in the Nuclear Fuel Cycle, p. 60 (2003)
2046	Fridman et al., <i>Plasma Physics and Engineering</i> , pp. 409-424, 639-40 (2nd ed. 2011)
2047	Laser Focus, p. 108 (Dec. 1985)
2048	Tidwell et al., " <u>Highly efficient 60-W TEM₀₀ cw diode-end-pumped Nd:YAG laser</u> ," <i>Optics Letters</i> , Vol. 18, No. 2, (1993)
2049	Shine et al., " <u>40-W cw, TEM₀₀-mode, diode-laser-pumped, Nd:YAG miniature-slab laser</u> ," <i>Optics Letters</i> , Vol. 20, No. 5, (1995)
2050	Schöne et al., " <u>Diode-Pumped High-Power cw Nd:YAG Lasers</u> ," <i>Laser in Forschung und Technik</i> (1996)
2051	Optics & Photonics News, January 1999
2052-2071	<Reserved>
2072	M. W. P. Cann, <i>Light Sources in the 0.15-20-μ Spectral Range</i> , Vol. 8 No. 8 Applied Optics (1969)
2073	Solarz, "Coherent DUV Illumination for Semiconductor Wafer Inspection," U.S. Patent No. 7,295,739 (Nov. 13, 2007)
2074-2080	<Reserved>
2081	Cremers et al., "Evaluation of the continuous optical discharge for spectrochemical analysis," <i>Spectrochimica Acta</i> , Vol. 40B, No. 4, pp. 665-679 (1985)
2082	D. Keefer, "Laser Sustained Plasmas," Chapter 4 in Radziemski et al., <i>Laser-Induced Plasmas and Applications</i> , pp. 169-206, CRC Press (1989)
2083	<Reserved>
2084	Webster's Third New International Dictionary of the English Language, Unabridged, "On," p. 1574-5 (2002)
2085	The American Heritage Dictionary of the English Language, "On,"

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